

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Meng Tao, et al.
Application No.: 10/822,343
Filing Date: April 12, 2004
Art Unit: 1775
Examiner: Timothy M. Speer
For: SUPPRESSION OF CHEMICAL REACTIVITY ON
SEMICONDUCTOR SURFACES

VIA EFS
Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

**AMENDMENT AFTER FINAL OFFICE ACTION
(Submission under 37 C.F.R. § 1.116)**

Dear Sir:

Applicants submit this Amendment after an Office Action made final and mailed May 14, 2007. Applicants respectfully request entry of the amendments set forth herein, consideration of the remarks provided with this paper, and allowance of the claims submitted herewith.

Applicants first wish to thank the Examiner for agreeing to and holding a telephone interview with Applicants' representatives on July 12, 2007, and for discussing the subject application for patent. Applicants submit that the Amendment and remarks provided herewith are in consideration of the substance of the interview held on July 12, 2007, and are in compliance with the rules for submitting a reply after final rejection under 37 C.F.R. 1.116. Accordingly, this reply only adopts examiner suggestions, cancels claims, complies with any requirement of form expressly set forth in the Office Action mailed May 14, 2007, or presents rejected claims in better form for consideration before appeal. No new matter has been introduced with this reply and no new issues

requiring further consideration and/or search have been introduced with the amended claims set forth herewith.

In view of the above, Applicant submits the following:

Amendments to the Claims provided as a Listing of Claims that begin on page 3; and

Statement of Substance of Interview that begins on page 5; and

Remarks that begin on page 6 of this paper.